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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Takeshi Fukada
Serial No. : 10/656,263
Filed : September 8, 2003
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

Art Unit : 2826
Examiner : Fazli Erdem

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

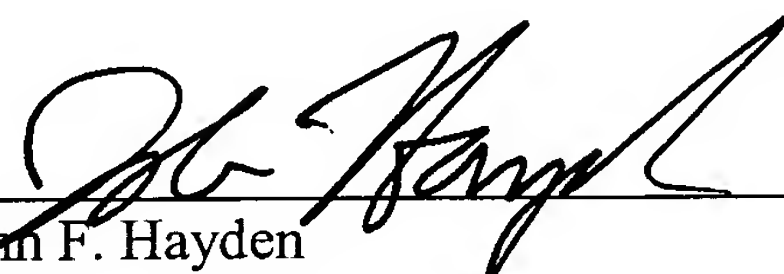
Responsive to the action mailed March 22, 2005, applicant elects the invention of Group I (claims 1-16, 33-40, 49-50, and 55-56) drawn to the a semiconductor device. The election is made without traverse.

No fees are believed to be due. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: _____

4/21/05


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